- 12. (Amended) A method according to Claim 7, wherein said step of cleaning outer surfaces of the electronic component chips is performed by washing outer surfaces of electronic component chips using a washing liquid.
- 13. (New) A method according to Claim 8, wherein said step of cleaning outer surfaces of the electronic component chips comprises a process of grinding outer surfaces of electronic component chips.
- 14. (New) A method according to Claim 8, wherein said step of cleaning outer surfaces of the electronic component chips is performed by washing outer surfaces of electronic component chips using a washing liquid.
- 15. (New) A method according to Claim 9, wherein said step of cleaning outer surfaces of the electronic component chips is performed by washing outer surfaces of electronic component chips using a washing liquid.
- 16. (New) A method according to Claim 10, wherein said step of cleaning outer surfaces of the electronic component chips is performed by washing outer surfaces of electronic component chips using a washing liquid

17. (New) A method according to Claim 11, wherein said step of cleaning outer surfaces of the electronic component chips is performed by washing outer surfaces of electronic component chips using a washing liquid.